

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuaki TAKAZAWA et al.

Application No.: New U.S. Patent Application

Filed: February 27, 2004

Docket No.: 118845

For: METHOD OF PRODUCTION, METHOD OF INSPECTION, AND METHOD OF USE  
OF SCANNING PROBE MICROSCOPE PROBE

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450.  
Alexandria, VA 22313-1450

Sir:

Please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**